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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Akinori KOUKITU et al.

Group Art Unit: 1792

Application No.: 10/509,177

Docket No.: 121213

Filed: September 27, 2004

For: VAPOR PHASE GROWTH METHOD FOR A1-CONTAINING III-V GROUP  
COMPOUND SEMICONDUCTOR, AND METHOD AND DEVICE FOR  
PRODUCING A1-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR

**SECOND REQUEST FOR CORRECTION OF PALM RECORDS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records. A Supplemental Application Data Sheet is attached.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075

Andrew B. Whitehead  
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JAO:ABW/tca

Date: February 26, 2009

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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ABW



## UNITED STATES PATENT AND TRADEMARK OFFICE

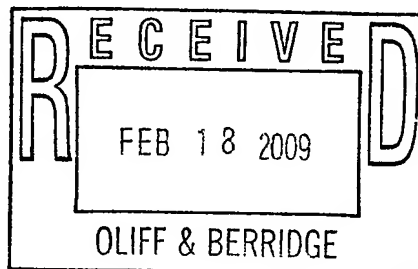
UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

APPLICATION NUMBER	FILING or 371(c) DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	TOT CLAIMS	IND CLAIMS
10/509,177	09/27/2004	1792	1092	121213	17	5

CONFIRMATION NO. 5228

25944

OLIFF & BERRIDGE, PLC  
 P.O. BOX 320850  
 ALEXANDRIA, VA 22320-4850



CORRECTED FILING RECEIPT



Date Mailed: 02/17/2009

Receipt is acknowledged of this non-provisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please submit a written request for a Filing Receipt Correction. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections**

Applicant(s).

**KOUKITU**  
 Akinori Koukitsu, Koganei-shi, JAPAN;  
 Yoshinao Kumagai, Koganei-shi, JAPAN;  
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Assignment For Published Patent Application

TOKYO UNIVERSITY AGRICULTURE AND TECHNOLOGY TLO CO., LTD., Koganei-shi,  
 JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 25944

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/04408 04/07/2003

Foreign Applications

JAPAN 2002-106102 04/09/2002

If Required, Foreign Filing License Granted: 09/22/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention,  
 is **US 10/509,177**

Projected Publication Date: Not Applicable

Non-Publication Request: No

Early Publication Request: No

**Title**

Vapor phase growth method for A1-containing III-V group compound semiconductor, and method and device for producing A1-containing III-V group compound semiconductor

**Preliminary Class**

117

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Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process **simplifies** the filing of patent applications on the same invention in member countries, but **does not result** in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

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For information on preventing theft of your intellectual property (patents, trademarks and copyrights), you may wish to consult the U.S. Government website, <http://www.stopfakes.gov>. Part of a Department of Commerce initiative, this website includes self-help "toolkits" giving innovators guidance on how to protect intellectual property in specific countries such as China, Korea and Mexico. For questions regarding patent enforcement issues, applicants may call the U.S. Government hotline at 1-866-999-HALT (1-866-999-4158).

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**Title 37, Code of Federal Regulations, 5.11 & 5.15**

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**OLIFF & BERRIDGE, PLC**

ATTORNEYS AT LAW

**Supplemental Application Data Sheet**

**Application Information**

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R:	None
Title::	VAPOR PHASE GROWTH METHOD FOR A1-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR, AND METHOD AND DEVICE FOR PRODUCING A1-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR
Attorney Docket Number::	121213
Suggested Drawing Figure::	
Total Drawing Sheets::	5
Small Entity::	No

**Applicant Information**

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
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Country of Residence::	JAPAN

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Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
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Applicant Authority type::	Inventor
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Country of Residence::	JAPAN

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**Correspondence Information**

Correspondence Customer Number:: 25944

<b>Domestic Priority Information</b>			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP03/04408	4/7/2003
<b>Foreign Priority Information</b>			
Country::	Application Number::	Filing Date::	Priority Claimed::
JAPAN	2002-106102	4/9/2002	Yes
<b>Assignee Information</b>			
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